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CONFIRMATION NO. 5289

SERIAL NUMBER 10/533,147	FILING OR 371(c) DATE 04/27/2005 RULE	CLASS 117	GROUP ART UNIT 1722	ATTORNEY DOCKET NO. 94198	
APPLICANTS Susumu Maeda, Kanagawa, JAPAN; Hiroshi Inagaki, Kanagawa, JAPAN; Shigeki Kawashima, Kanagawa, JAPAN; Shoei Kurosaka, Kanagawa, JAPAN; Kozo Nakamura, Kanagawa, JAPAN;					
** CONTINUING DATA ***** This application is a 371 of PCT/JP03/14001 10/31/2003 ** FOREIGN APPLICATIONS ***** JAPAN 2002-317955 10/31/2002					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and <i>S.M. Maeda</i> Acknowledged <i>Smm</i> Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 6	TOTAL CLAIMS 10	INDEPENDENT CLAIMS 3
ADDRESS 24628					
TITLE Method for producing silicon wafer					
FILING FEE RECEIVED 1000	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		